

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Atty Dkt. 2476-37

C# M#

CHEN et al.

C/A.U.

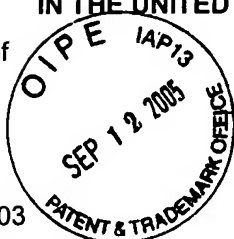
2815

Serial No. 10/730,381

Examiner: Jackson Jr., Jerome

Filed: 09 December 2003

Date: September 12, 2005

Title: PROGRAMMABLE PHOTOLITHOGRAPHIC MASK BASED ON  
SEMICONDUCTOR NANO-PARTICLE OPTICAL MODULATORSCommissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**RESPONSE/AMENDMENT/LETTER**

This is a response/amendment/letter in the above-identified application and includes an attachment which is hereby incorporated by reference and the signature below serves as the signature to the attachment in the absence of any other signature thereon.

☐ **Correspondence Address Indication Form Attached.****Fees are attached as calculated below:**

Total effective claims after amendment 39 minus highest number  
previously paid for 39 (at least 20) = 0 x \$50.00 \$0.00 (1202)/\$0.00 (2202) \$

Independent claims after amendment 4 minus highest number  
previously paid for 4 (at least 3) = 0 x \$200.00 \$0.00 (1201)/\$0.00 (2201) \$

If proper multiple dependent claims now added for first time, (ignore improper); add  
\$360.00 (1051)/\$180.00 (2051) \$

Petition is hereby made to extend the current due date so as to cover the filing date of this  
paper and attachment(s)

One Month Extension \$120.00 (1251)/\$60.00 (2251)  
Two Month Extensions \$450.00 (1252)/\$225.00 (2252)  
Three Month Extensions \$1020.00 (1253)/\$510.00 (2253)  
Four Month Extensions \$1590.00 (1254)/\$795.00 (2254) \$ 60.00

Terminal disclaimer enclosed, add \$130.00 (1814)/\$65.00 (2814) \$

☐ Applicant claims "small entity" status. ☐ Statement filed herewith

Rule 56 Information Disclosure Statement Filing Fee \$180.00 (1806) \$

Assignment Recording Fee \$40.00 (8021) \$

Other: \$

**TOTAL FEE ENCLOSED \$ 60.00**

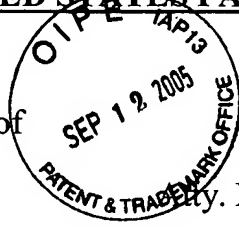
The Commissioner is hereby authorized to charge any deficiency, or credit any overpayment, in the fee(s) filed, or asserted to be filed, or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Account No. 14-1140. A duplicate copy of this sheet is attached.

901 North Glebe Road, 11th Floor  
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Telephone: (703) 816-4000  
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RWF:ejNIXON & VANDERHYE P.C.  
By Atty: Robert W. Faris, Reg. No. 31,352Signature: 

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

CHEN et al.



Ref.: 2476-37; Confirmation No. 2846

Appl. No. 10/730,381

TC/A.U. 2815

Filed: 09 December 2003

Examiner: Jackson Jr., Jerome

For: PROGRAMMABLE PHOTOLITHOGRAPHIC MASK BASED ON  
SEMICONDUCTOR NANO-PARTICLE OPTICAL MODULATORS

\* \* \* \* \*

September 12, 2005

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**RESPONSE TO RESTRICTION REQUIREMENT**

Responsive to the Official Action of July 12, 2005 and the requirement for  
restriction presented in it (for which a one-month time extension is hereby requested),  
applicants elect the species of Group 4, that is claim 27.

An examination on the merits is awaited.

09/14/2005 HALI11

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60.00 OP

Respectfully submitted,

**NIXON & VANDERHYE P.C.**

By: 

Robert W. Faris  
Reg. No. 31,352

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